



012306

Docket No.: 2002-0048-02
 Serial No.: 10/699,228
 Inventor(s): Richard L. Sandstrom
 Title: Etalon Testing System and Process
 REPLACEMENT SHEET

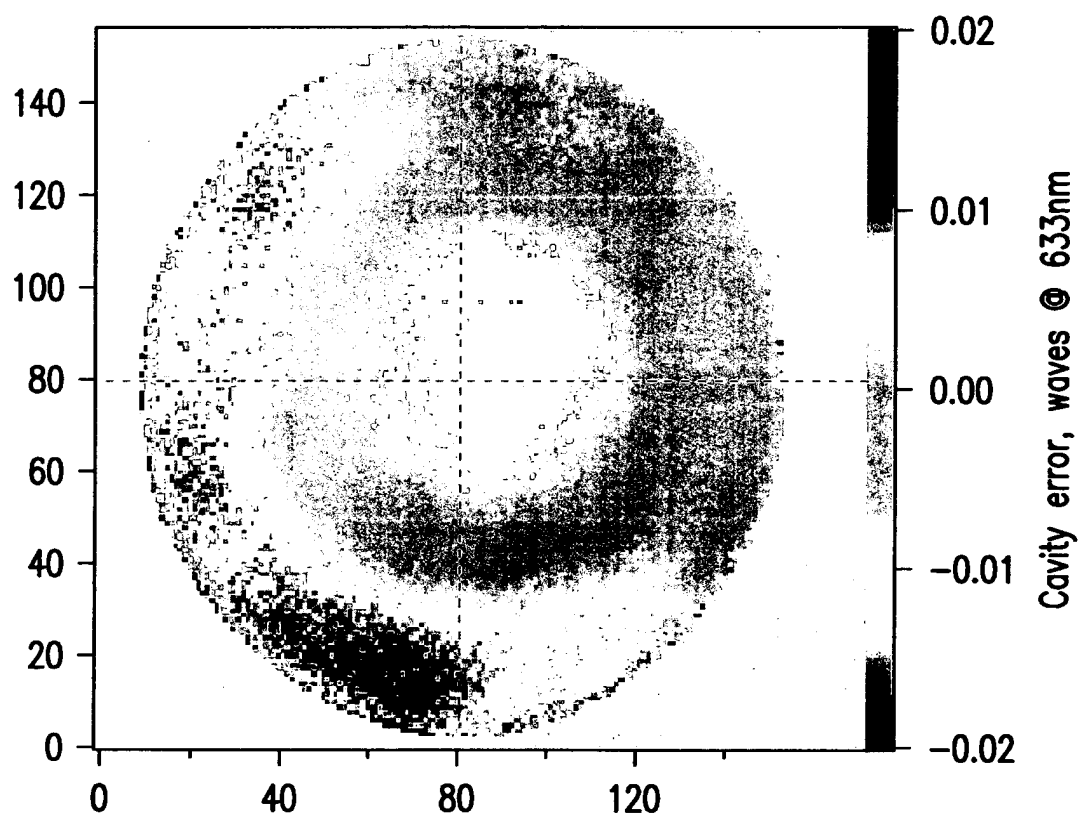


FIG. 4A

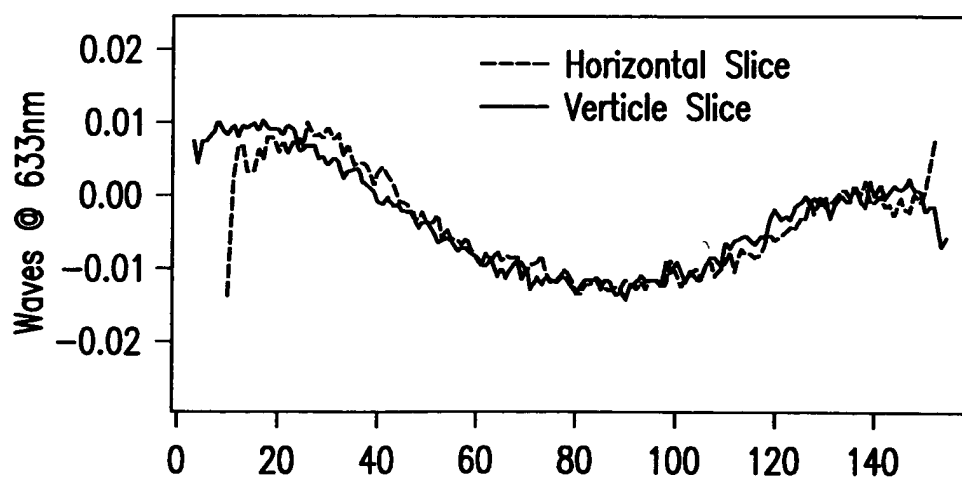


FIG. 4B

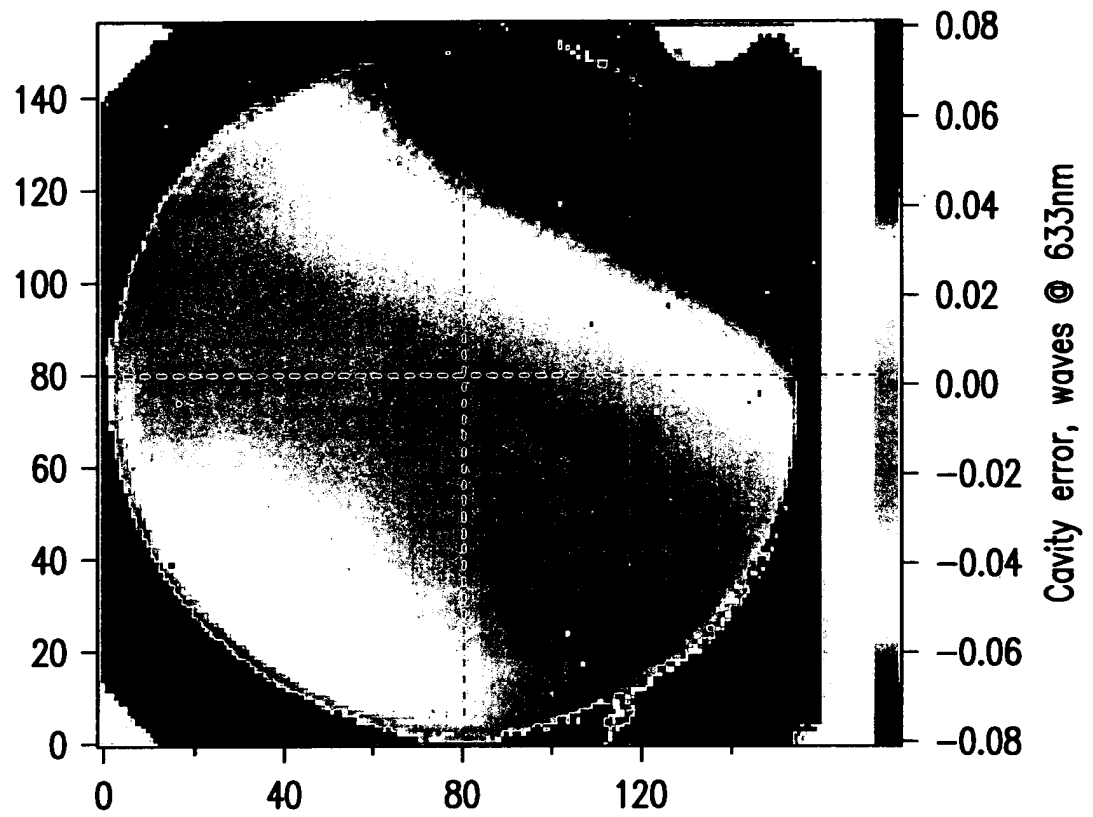


FIG.5A

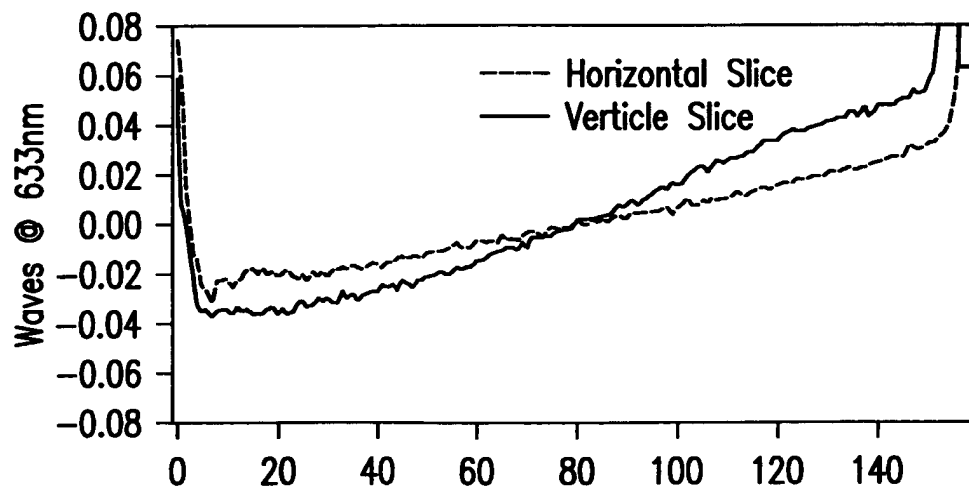
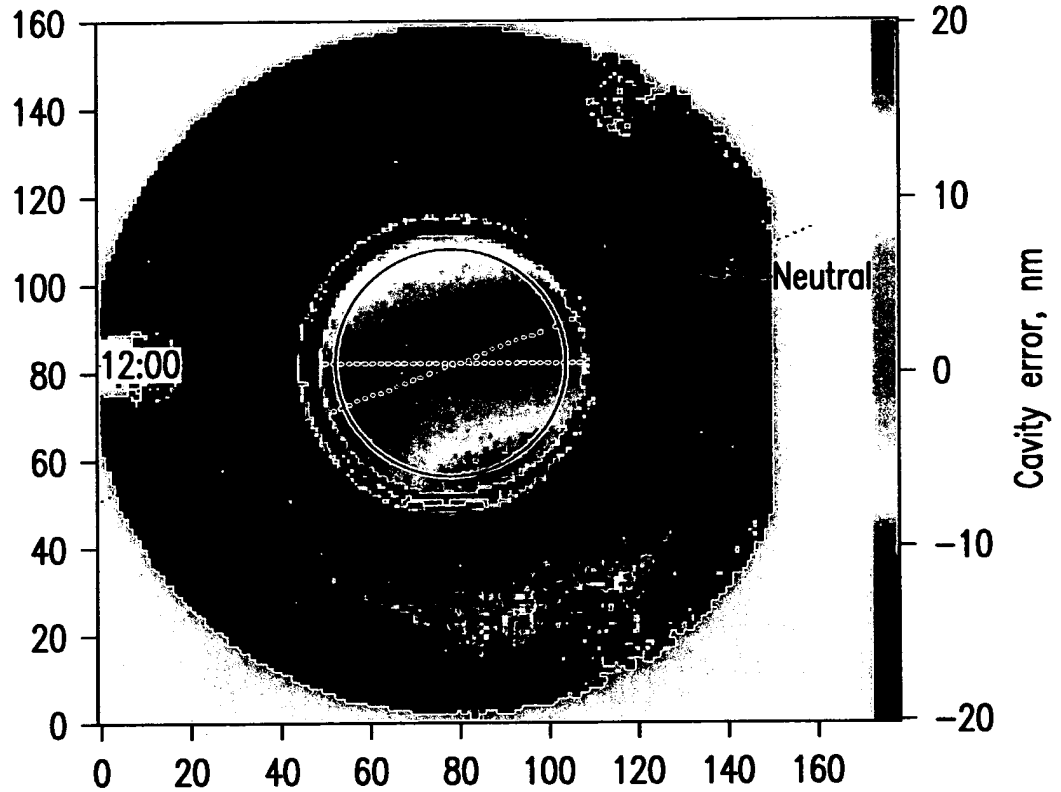


FIG.5B



Mask diameter = 9.8113mm
Spherical curvature over mask area: 0.0023042 waves 1.4581nm
Cavity wedge: 0.03534 waves/cm 22.363nm/cm
Wedge neutral axis: 21.238 degrees

FIG.6A

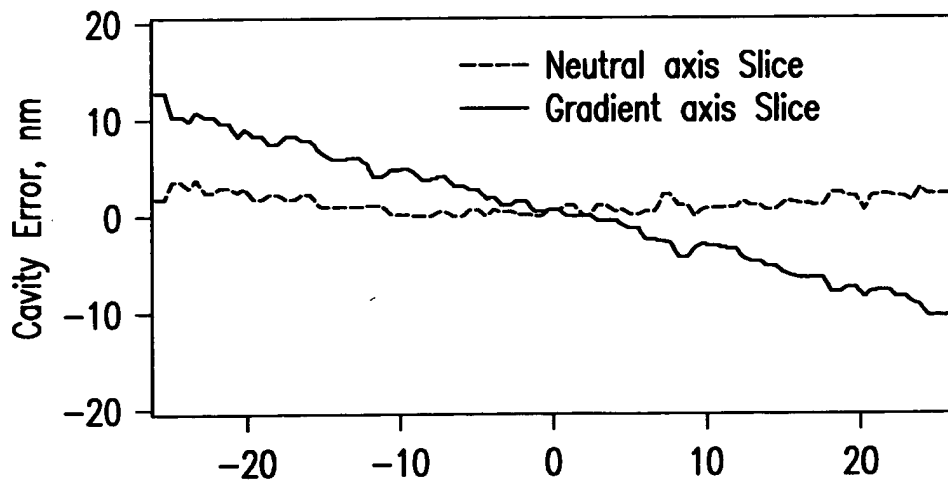
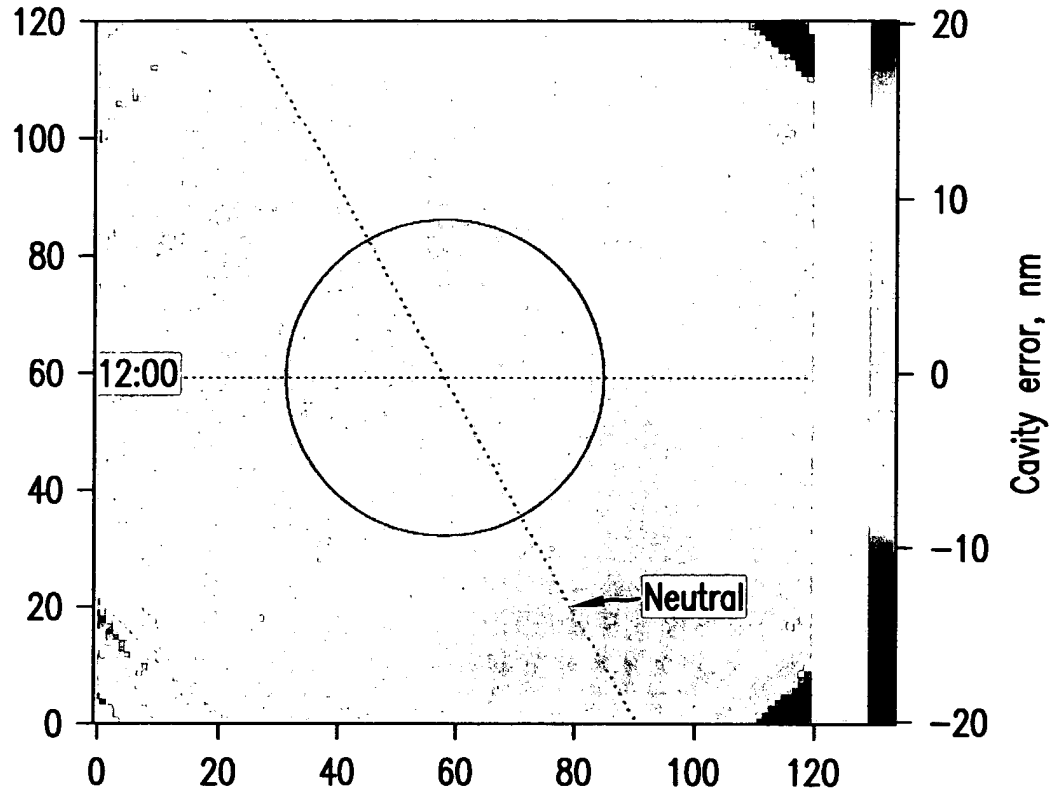


FIG.6B



Mask diameter = 10.131mm
Spherical curvature over mask area: -0.00012564 waves -0.079503 nm
Cavity wedge: 0.00083653 waves/cm 0.52936 nm/cm
Wedge neutral axis: -61.113 degrees

FIG.7A

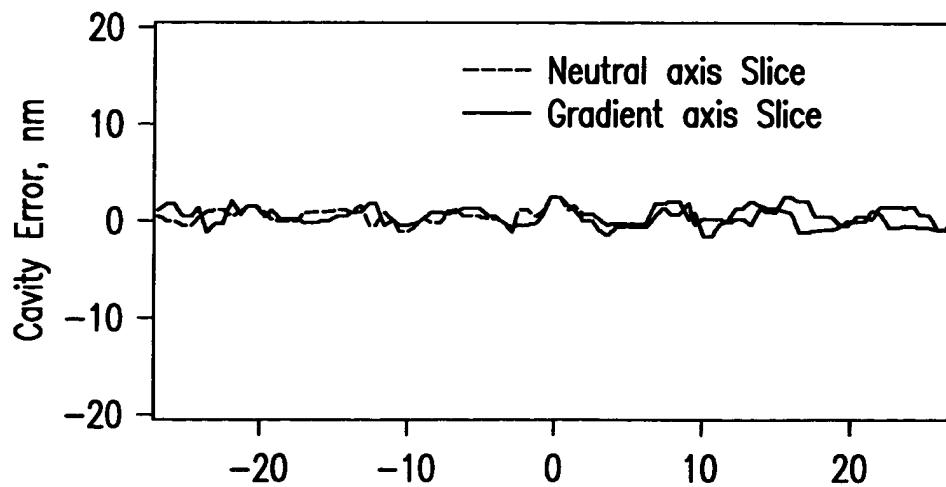


FIG.7B